

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Brian Vialpando, et al.

Docket No: TI-35829

Serial No:

10/727,392

Conf. No:

7423

Examiner:

Karl D. Easthom

Art Unit:

2832

Filed:

12/04/2003

For:

THIN FILM RESISTOR STRUCTURE AND METHOD OF FABRICATING A THIN FILM

RESISTOR STRUCTURE

ELECTION

Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450 MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 4-8-05

Dear Sir:

This election is offered in response to the Examiner's restriction requirement mailed March 17, 2005.

Applicants hereby elect to pursue Group II of Claims 10-21, drawn to method of making a resistor, without traversing the Examiner's restriction requirement.

Respectfully submitted,

Peter K. McLarty

Attorney for Applicants

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